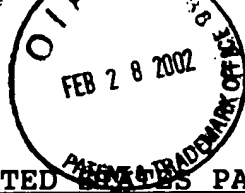
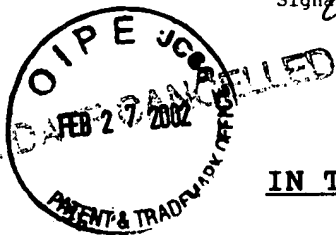


I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, D.C. 20231, ON FEB 28 2002 Depositor: R.C. ING - m ARS

Karen C. Ing. Mars 2/14/02
Signature & Date



COPY OF PAPERS
ORIGINALLY FILED

#2
CFR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit 2877

In re application of : February 14, 2002
Ausschnitt et al. : Examiner:
Serial No. 10/035,061 : IBM Corporation
Dept. 18G/Bldg. 300-482
Filed: December 28, 2001 : 2070 Route 52,
Hopewell Junction,
New York 12533-6531
Title: PHASE SHIFTED TEST
PATTERN FOR MONITORING FOCUS
AND ABERRATIONS IN OPTICAL
PROJECTION SYSTEMS

RECEIVED
MAR 27 2002
TECHNOLOGY CENTER 2800

REQUEST FOR CORRECTION OF OFFICIAL FILING RECEIPT

Commissioner of Patents
Washington, D.C. 20231

Sir:

Upon receiving the filing receipt (attached) for the above-captioned patent application, it was noted that one of the inventors names was incorrect. The name should be: CHRISTOPHER P. AUSSCHNITT. In addition, the assignee's city should be corrected to read ARMONK.

No fee is believed to be necessary.

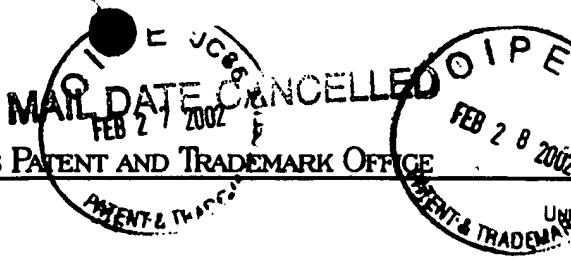
Respectfully submitted,

By:

Todd M. C. Li

Todd M. C. Li
Registration No. 45,554
Telephone: (845)894-6919

TML/kcm



Page 1 of 2
COPY OF PAPERS
ORIGINALLY FILED

UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRANT UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/035,061	12/28/2001	2877	824	FIS9-2001-0254 us1	12	20	4

CONFIRMATION NO. 3269

FILING RECEIPT



OC00000007408765

Todd M. C. Li
IBM Corporation-Zip 482
2070 Route 52
Hopewell Junction, NY 12533

Date Mailed: 02/01/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Christopher P. Ausachnitt, Lexington, MA; ✓
Timothy A. Brunner, Ridgefield, CT; ✓
Joseph P. Kirk, Chelsea, NY; ✓
Nakgeun Seong, Wappingers Falls, NY; ✓

Assignment For Published Patent Application

INTERNATIONAL BUSINESS MACHINES CORPORATION, aRMONK, NY;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 02/01/2002

Projected Publication Date: 07/03/2003

Non-Publication Request: No

Early Publication Request: No

Title

RECEIVED
MAR 27 2002
TECHNOLOGY CENTER 2800

FEB 28 2002

Phase shifted test pattern for monitoring focus and aberrations in optical projection systems

Preliminary Class
356COPY OF PAPERS
ORIGINALLY FILED

FEB 27 2002

LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15

GRANTED

The applicant has been granted a license under 35 U.S.C. 184, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" followed by a date appears on this form. Such licenses are issued in all applications where the conditions for issuance of a license have been met, regardless of whether or not a license may be required as set forth in 37 CFR 5.15. The scope and limitations of this license are set forth in 37 CFR 5.15(a) unless an earlier license has been issued under 37 CFR 5.15(b). The license is subject to revocation upon written notification. The date indicated is the effective date of the license, unless an earlier license of similar scope has been granted under 37 CFR 5.13 or 5.14.

This license is to be retained by the licensee and may be used at any time on or after the effective date thereof unless it is revoked. This license is automatically transferred to any related applications(s) filed under 37 CFR 1.53(d). This license is not retroactive.

The grant of a license does not in any way lessen the responsibility of a licensee for the security of the subject matter as imposed by any Government contract or the provisions of existing laws relating to espionage and the national security or the export of technical data. Licensees should apprise themselves of current regulations especially with respect to certain countries, of other agencies, particularly the Office of Defense Trade Controls, Department of State (with respect to Arms, Munitions and Implements of War (22 CFR 121-128)); the Office of Export Administration, Department of Commerce (15 CFR 370.10 (j)); the Office of Foreign Assets Control, Department of Treasury (31 CFR Parts 500+) and the Department of Energy.

NOT GRANTED

No license under 35 U.S.C. 184 has been granted at this time, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" DOES NOT appear on this form. Applicant may still petition for a license under 37 CFR 5.12, if a license is desired before the expiration of 6 months from the filing date of the application. If 6 months has lapsed from the filing date of this application and the licensee has not received any indication of a secrecy order under 35 U.S.C. 181, the licensee may foreign file the application pursuant to 37 CFR 5.15(b).

RECEIVED
MAR 27 2002
TECHNOLOGY CENTER 2800